



**EXPEDITED PROCEDURE - EXAMINING GROUP 1744**

**10/692,881**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Sharone Gindel	Examiner:	Theresa T. Snider
Serial No.:	10/692,881	Group Art Unit:	1744
Filed:	October 24, 2003	Docket No.:	884.422US2
Title:	VACUUM DEBRIS REMOVAL SYSTEM FOR AN INTEGRATED CIRCUIT MANUFACTURING DEVICE		
Assignee:	Intel Corporation	Customer No.:	21186

**AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed March 7, 2005, please amend the application as follows:

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6/22/05

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